

VIA EFS  
Docket No.: 199372003910  
(PATENT)  
Client Ref. No. 146630US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Naoki SHINDO et al.

Application No.: 10/779,397

Confirmation No.: 2798

Filed: February 13, 2004

Art Unit: 1792

For: SUBSTRATE PROCESSING APPARATUS  
AND SUBSTRATE PROCESSING METHOD

Examiner: Alexander Markoff

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

DO NOT ENTER: /A.M./

05/05/2010

Dear Sir:

**INTRODUCTORY COMMENTS**

This is in response to the final Office Action dated November 24, 2009, for which a response was due on February 24, 2010. Filed herewith is a Petition and fee for a two-month extension of time, thereby extending the deadline for response to April 26, 2010, the next succeeding business day after April 24, 2010. Accordingly, this response is timely filed. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.